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Inventor Name Search Result

Your Search was:

Last Name = MITROVIC

First Name = ANDREI

Application#	Patent	Status	Date Filed	Title	Inventor Name
60458043	Not Issued	159	03/28/2003	METHOD AND SYSTEM FOR TEMPERATURE CONTROL OF A SUBSTRATE	MITROVIC, ANDREI
60414348	Not Issued	159	09/30/2002	APPARATUS AND METHOD FOR USE OF OPTICAL SYSTEM WITH A PLASMA PROCESSING SYSTEM	MITROVIC, ANDREI
60362716	Not Issued	159	03/28/2002	APPARATUS AND METHOD FOR USE OF OPTICAL DIAGNOSTIC SYSTEM WITH A PLASMA PROCESSING SYSTEM	MITROVIC, ANDREI
60333434	Not Issued	159	01/31/2002	METHOD AND STRUCTURE TO SEGMENT RF COUPLING TO ELECTRODE	MITROVIC, ANDREI
60332546	Not Issued	159	01/31/2002	METHOD AND APPARATUS FOR DETERMINATION AND CONTROL OF PLASMA STATE	MITROVIC, ANDREI
60330722	Not Issued	159	10/31/2001	APPLIED PLASMA DUCT SYSTEM	MITROVIC, ANDREI
60318828	Not Issued	159	09/14/2001	PLASMA REACTOR COIL MAGNET SYSTEM	MITROVIC, ANDREI
60308447	Not Issued	159	07/30/2001	PLASMA CHAMBER WALL SEGMENT TEMPERATURE CONTROL	MITROVIC, ANDREI
60301433	Not Issued	159	06/29/2001	METHOD OF AND APPARATUS FOR MEASURING AND CONTROLLING WATER CHUCK TEMPERATURE USING ULTRASONIC TOMOGRAPHY	MITROVIC, ANDREI
60288877	Not Issued	159	06/19/2001	CLOSED-DRAFT HALL EFFECT PLASMA VACUUM PUMP FOR PROCESS REACTORS	MITROVIC, ANDREI
60286145	Not Issued	159	06/07/2001	APPARATUS AND METHOD FOR DETERMINING CLAMPING STATUS OF SEMICONDUCTOR WAFER	MITROVIC, ANDREI
60272722	Not Issued	159	03/30/2001	OPTICAL SYSTEM AND METHOD FOR PLASMA OPTICAL EMISSION ANALYSIS	MITROVIC, ANDREI
60272434	Not Issued	159	03/02/2001	APPARATUS AND METHOD OF IMPROVING CAPACITIVELY COUPLED RF VOLTAGE PROBE	MITROVIC, ANDREI
60239861	Not Issued	159	01/08/2001	ADDITION OF POWER AT SELECTED HARMONICS OF PLASMA PROCESSOR DRIVE FREQUENCY	MITROVIC, ANDREI
6024214	Not Issued	159	10/25/2000	METHOD OF AND STRUCTURE FOR CONTROLLING ELECTRODE TEMPERATURE	MITROVIC, ANDREI
11082246	Not Issued	030	03/17/2005	PLASMA PROCESSING SYSTEM AND METHOD	MITROVIC, ANDREI
10293112	Not Issued	030	11/23/2004	METHOD OF AND APPARATUS FOR MEASURING AND CONTROLLING SUBSTRATE HOLDER TEMPERATURE USING ULTRASONIC TOMOGRAPHY	MITROVIC, ANDREI

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10672346	Not Issued	041	01/30/2004	METHOD AND APPARATUS FOR DETERMINING CHEMISTRY OF PARTS RESIDUAL CONTAMINATION	MITROVIC, ANDREI
10673321	Not Issued	041	09/30/2003	METHOD AND APPARATUS FOR DETERMINING PLASMA IMPEDANCE	MITROVIC, ANDREI
10673138	Not Issued	030	09/30/2003	SYSTEM AND METHOD FOR USING FIRST PRINCIPLES SIMULATION TO FACILITATE A SEMICONDUCTOR MANUFACTURING PROCESS	MITROVIC, ANDREI
10612824	Not Issued	150	07/03/2003	ADDITION OF POWER AT SELECTED HARMONICS OF PLASMA PROCESSOR DRIVE FREQUENCY	MITROVIC, ANDREI
10478692	Not Issued	071	12/08/2003	APPARATUS AND METHOD FOR DETERMINING CLAMPING STATUS OF SEMICONDUCTOR WAFER	MITROVIC, ANDREI
10469292	Not Issued	094	02/26/2004	APPARATUS AND METHOD OF IMPROVING IMPEDANCE MATCHING BETWEEN AN RF SIGNAL AND A MULTI-SEGMENTED ELECTRODE	MITROVIC, ANDREI
10399981	Not Issued	071	04/24/2003	METHOD OF AND STRUCTURE FOR CONTROLLING ELECTRODE TEMPERATURE	MITROVIC, ANDREI
10388540	Not Issued	030	03/17/2003	APPARATUS AND METHOD FOR USE OF OPTICAL DIAGNOSTIC SYSTEM WITH A PLASMA PROCESSING SYSTEM	MITROVIC, ANDREI
10359557	Not Issued	061	02/07/2003	METHOD AND APPARATUS FOR IMPROVED PLASMA PROCESSING UNIFORMITY	MITROVIC, ANDREI
10351173	Not Issued	150	01/31/2003	METHOD AND APPARATUS FOR DETERMINATION AND CONTROL OF PLASMA STATE	MITROVIC, ANDREI
10189425	Not Issued	150	07/08/2002	SEGMENTED ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	MITROVIC, ANDREI
10183360	Not Issued	161	06/28/2002	METHOD OF AND APPARATUS FOR MEASURING AND CONTROLLING SUBSTRATE HOLDER TEMPERATURE USING ULTRASONIC TOMOGRAPHY	MITROVIC, ANDREI
10096932	Not Issued	150	03/14/2002	OPTICAL SYSTEM AND METHOD FOR PLASMA OPTICAL EMISSION ANALYSIS	MITROVIC, ANDREI

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Last Name = MITROVIC
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Application#	Patent	Status	Date Filed	Title	Inventor Name
60458442	Not Issued	159	03/31/2003	PLASMA PROCESSING SYSTEM AND METHOD	MITROVIC, ANDREI S.
60453582	Not Issued	159	03/27/2003	METHOD AND SYSTEM FOR MONITORING RF IMPEDANCE TO DETERMINE CONDITIONS OF A WAFER ON AN ELECTROSTATIC CHUCK	MITROVIC, ANDREI S.
60432982	Not Issued	159	11/26/2002	PLASMA PROCESSING SYSTEM AND METHOD	MITROVIC, ANDREI S.
60413432	Not Issued	159	09/30/2002	PLASMA PROCESSING SYSTEM AND METHOD	MITROVIC, ANDREI S.
60413122	Not Issued	159	12/31/2001	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	MITROVIC, ANDREI S.
60368912	Not Issued	159	02/16/2001	METHOD AND APPARATUS FOR TRANSPERRING HEAT FROM A SUBSTRATE TO A CHUCK	MITROVIC, ANDREI S.
60231312	Not Issued	159	11/28/2000	METHOD AND APPARATUS FOR 2-D SPATIALLY RESOLVED OPTICAL EMISSION AND ABSORPTION SPECTROSCOPY	MITROVIC, ANDREI S.
60223834	Not Issued	159	08/08/2000	METHOD AND APPARATUS FOR IMPROVED PLASMA PROCESSING UNIFORMITY	MITROVIC, ANDREI S.
60182188	Not Issued	159	02/14/2000	DEVICE AND METHOD FOR COUPLING TWO CIRCUIT COMPONENTS WHICH HAVE DIFFERENT IMPEDANCES	MITROVIC, ANDREI S.
60182187	Not Issued	159	02/14/2000	METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	MITROVIC, ANDREI S.
60132384	Not Issued	159	01/10/2000	SEGMENTED ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	MITROVIC, ANDREI S.
11082222	Not Issued	030	03/17/2003	APPARATUS AND METHOD FOR USE OF OPTICAL SYSTEM WITH A PLASMA PROCESSING SYSTEM	MITROVIC, ANDREI S.
11065065	Not Issued	030	02/25/2003	CHUCK PEDESTAL SHIELD	MITROVIC, ANDREI S.
10812075	Not Issued	095	03/31/2004	LOW REFLECTION MICROWAVE WINDOW	MITROVIC, ANDREI S.
10811912	Not Issued	030	03/30/2004	HONEYCOMB OPTICAL WINDOW DEPOSITION SHIELD AND METHOD FOR A PLASMA PROCESSING SYSTEM	MITROVIC, ANDREI S.
10807432	Not Issued	030	03/24/2004	METHOD AND SYSTEM FOR MONITORING RF IMPEDANCE TO DETERMINE CONDITIONS OF A WAFER ON AN ELECTROSTATIC CHUCK	MITROVIC, ANDREI S.
10793815	Not Issued	030	03/08/2004	PLASMA REACTOR COIL MAGNET	MITROVIC, ANDREI S.
10793253	Not Issued	030	03/05/2004	METHOD AND APPARATUS FOR IMPROVED PLASMA PROCESSING UNIFORMITY	MITROVIC, ANDREI S.
1076347	Not Issued	041	01/20/2004	METHOD AND SYSTEM FOR MONITORING	MITROVIC, ANDREI S.

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10765445	Not Issued	020	01/28/2004	PLASMA CHAMBER WALL SEGMENT TEMPERATURE CONTROL	MITROVIC, ANDREI S.
10729948	Not Issued	150	12/19/2003	CLOSED-DRIFT HALL EFFECT PLASMA VACUUM PUMP FOR PROCESS REACTORS	MITROVIC, ANDREI S.
10720052	Not Issued	020	11/25/2003	PLASMA PROCESSING SYSTEM AND METHOD	MITROVIC, ANDREI S.
10633583	Not Issued	030	09/30/2003	SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES SIMULATION TO PROVIDE VIRTUAL SENSORS THAT FACILITATE A SEMICONDUCTOR MANUFACTURING PROCESS	MITROVIC, ANDREI S.
10621501	Not Issued	030	09/30/2003	SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES SIMULATION TO CHARACTERIZE A SEMICONDUCTOR MANUFACTURING PROCESS	MITROVIC, ANDREI S.
10609510	Not Issued	061	08/13/2003	METHOD AND APPARATUS FOR TRANSPERRING HEAT FROM A SUBSTRATE TO A CHUCK	MITROVIC, ANDREI S.
10611202	Not Issued	161	07/03/2003	CAPACITIVELY COUPLED RF VOLTAGE PROBE	MITROVIC, ANDREI S.
10432213	Not Issued	094	05/27/2003	METHOD AND APPARATUS FOR 2-D SPATIALLY RESOLVED OPTICAL EMISSION AND ABSORPTION SPECTROSCOPY	MITROVIC, ANDREI S.
10357454	Not Issued	095	02/04/2003	CONTROL METHOD FOR SEGMENTED ELECTRODE APPARATUS AND METHOD FOR PLASMA PROCESSING	MITROVIC, ANDREI S.
10355202	Not Issued	150	01/31/2003	METHOD AND STRUCTURE TO SEGMENT RF COUPLING TO SILICON ELECTRODE	MITROVIC, ANDREI S.
10335828	Not Issued	150	12/23/2002	LINEAR INDUCTIVE PLASMA PUMP FOR PROCESS REACTORS	MITROVIC, ANDREI S.
10283358	Not Issued	150	10/30/2002	APPLIED PLASMA DUCT SYSTEM	MITROVIC, ANDREI S.
10218114	Not Issued	150	08/14/2002	DEVICE AND METHOD FOR COUPLING TWO CIRCUIT COMPONENTS WHICH HAVE DIFFERENT IMPEDANCES	MITROVIC, ANDREI S.
10218036	Not Issued	150	08/14/2002	METHOD AND DEVICE FOR ATTENUATING HARMONICS IN SEMICONDUCTOR PLASMA PROCESSING SYSTEMS	MITROVIC, ANDREI S.

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